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Dkt. 2271/60617

DEC 3 1 2000 E

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of:

Yoshinori UEDA

Serial No.

09/431,593

Date Filed

November 1, 1999

Group Art Unit: 28

Examiner: M. E. Warren

For

SEMICONDUCTOR DEVICE HAVING AN

INTEGRAL RESISTANCE ELEMENT

1185 Avenue of the Americas Rew York, N.Y. 10036

Assistant Commissioner for Patents Washington, D.C. 20231

AMENDMENT

Sir:

In response to the first Office Action dated August 1, 2001, please amend the above-identified application as follows:

In the Claims:

Please amend claims 1 and 7 as follows:

1. (Amended)

A semiconductor device, comprising:

Si substrate; and

a resistance element formed on said Si substrate,

I hereby certify that this paper is being deposited this date with the U.S. Postal Service as first class mail addressed to the Assistant

Commissioner for Patents Washington D.C. 20231

Richard F. Jaworski

Reg. No. 33,515

6/200/ Date

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